

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	)	ATOMIC LAYER DEPOSITION
	)	METHOD AND SEMICONDUCTOR
Hwang et al.	)	DEVICE FABRICATING
	)	APPARATUS HAVING ROTATABLE
Application No.	)	GAS INJECTORS
	)	Group Art Unit:
Filing Date:	)	
		Examiner:

Commissioner for Patents  
P.O. Box 1450  
Mail Stop: Divisional Patent Application  
Alexandria, VA 22313-1450

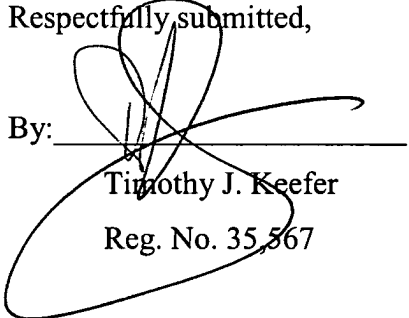
REMARKS

Applicant hereby requests that prosecution of this application proceed on claims 1-3. In view of the foregoing amendmens, Applicant submits that the present application is now in condition for allowance. An early allowance of the application is earnestly solicited.

Date: 8/18/03

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Respectfully submitted,

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